

0557-4909-3

\*RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 1753

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

KAZUNORI ITO ET AL

:

EXAMINER: MCDONALD, R. G.

SERIAL NO: 09/498,375

:

FILED: FEBRUARY 4, 2000

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GROUP ART UNIT: 1753

FOR: OPTICAL DEVICE SUBSTRATE  
FILM-FORMATION APPARATUS,  
OPTICAL DISK SUBSTRATE FILM-  
FORMATION METHOD, SUBSTRATE  
HOLDER MANUFACTURE METHOD,  
SUBSTRATE HOLDER, OPTICAL DISK  
AND A PHASE-CHANGE RECORDING TYPE  
OF OPTICAL DISK

Entered  
for CPA  
Request  
4/23/03  
W.M.

# B  
12/w.m.  
4/23/03  
(RE)

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Official Action mailed January 14, 2003, please amend this application as follows:

IN THE CLAIMS

Please amend Claims 1, 6, 11, 15, 19 and 73 to read as follows:<sup>1</sup>

B1

1. (Twice Amended) An optical disk substrate film-formation apparatus which manufactures an optical disk by forming a thin film on the surface of a substrate, said apparatus comprising:  
a substrate holder which fixes said substrate during the formation of said film,

<sup>1</sup>A marked-up copy of the changes made to these claims is attached.